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PATENT NUMBER and  
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## U.S. UTILITY Patent Application

31046 U.S. PTO  
10/029158  
JCM37



APPL NUM	FILING DATE	CLASS	SUBCLASS	GAU	EXAMINER
10029158	12/21/2001	451	285	3723	PACIHOBA

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**\*\*CONTINUING DATA VERIFIED:**

THIS APPLICATION IS A CIP OF 09/628,563 07/31/2000  
AND CLAIMS BENEFIT OF 60/259,016 12/29/2000

**\*\* FOREIGN APPLICATIONS VERIFIED:**

PCT/US01/41513 07/31/2001

PG-PUB	DO NOT PUBLISH <input type="checkbox"/>	RESCIND <input type="checkbox"/>
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials		ATTORNEY DOCKET NO A-69175-1/MSS
TITLE : Apparatus and method for chemical mechanical polishing of substrates		

U.S. DEPT. OF COMM./PAT. & TM.-PTO-436L (Rev. 12-94)

NOTICE OF ALLOWANCE MAILED		CLAIMS ALLOWED	
		Total Claims	Print Claim for 0.6
Assistant Examiner		DRAWING	
ISSUE FEE Amount Due      Date Paid		Sheets Drwg.	Figs. Drwg.
		Print Fig.	
<input type="checkbox"/> TERMINAL DISCLAIMER		Primary Examiner	
		Application Examiner	
		PREPARED FOR ISSUE	
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